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July 28 2003

To: Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

ATTN: GROUP ART UNIT 2823 M. ESTRADA

FR: Stephen B. Ackerman Reg. No. 37761  
28 Davis Avenue  
Poughkeepsie  
NY 12603  
Subject:

Serial No. 10/042,573 01/09/02

"Removal of SiON residue after CMP"

K-H Wei, K-W Chen, S-T Chang, Y-K Lin,  
T-C Wang, and Y-L Wang

Grp. Art Unit : 1742 M. Estrada

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AUG 15 2003  
TECHNOLOGY CENTER 2800

#### RESPONSE TO PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated May 2 2003, in the above identified application for patent, please enter the following amendments and consider the following remarks.

#### CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents and Trademarks, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 31, 2003.

Name

STEPHEN B. ACKERMAN REG. NO. 37,761

Signature/Date

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